UNITED STATES PATENT AND TRADEMARK OFFICE



17th Annual Berkeley - Stanford Advanced Patent Law Institute

Perspectives from the USPTO

December 9th, 2016

John Cabeca

West Coast Regional Director
United States Patent and Trademark Office





- 2016 Year in Review
- Enhancing Patent Quality
- Subject Matter Eligibility
- Open Data Portal



FY 2016 Patent Filings



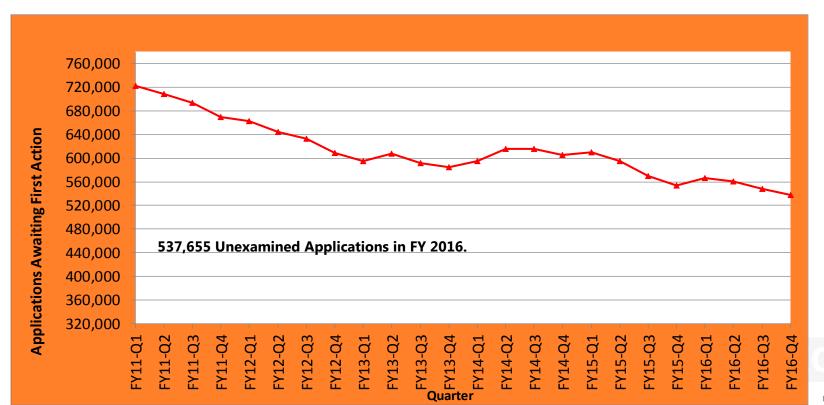
- + **5.1**% over FY 2015
- + 1.6% Serialized over FY 2015

75% Large 21.8% Small 3.2% Micro

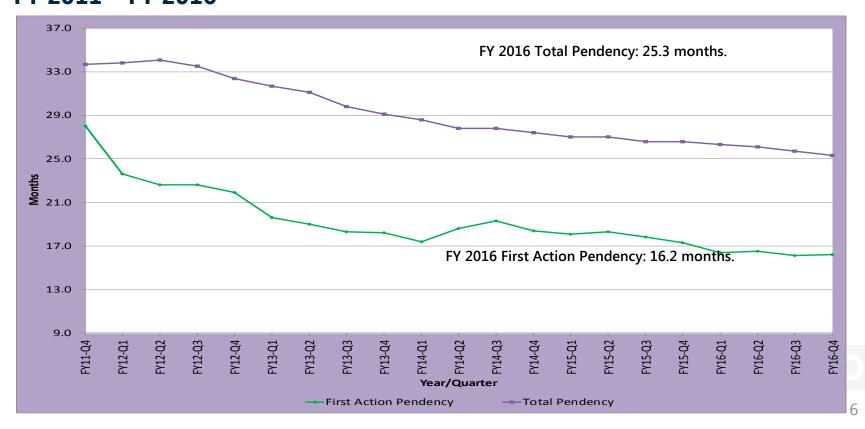


Unexamined Patent Application Inventory

FY 2011 – FY 2016



First Action Pendency and Total Pendency FY 2011 – FY 2016



Enhancing Patent Quality

Update on Pilots and Initiatives



Patent Quality Pillars



Pillar 1 – Excellence in Work Products



Pillar 2 – Excellent in Measuring Patent Quality



Pillar 3 – Excellence in Customer Service



EPQI Programs









Data Analysis

Pillar 1

 Topic Submission for Case Studies

Pillar 2

- Clarity and Correctness
 Data Capture (Master Review Form or MRF)
- Quality Metrics

Examiners' Resources, Tools & Training

Pillar 1

- Automated Pre-Examination Search Pilot
- STIC Awareness Campaign
- Improving Clarity and Reasoning in Office Actions Training (ICR Training)
- Post Grant Outcomes

Pillar 3

Interview Specialist

Changes to Process/Product

Pillar 1

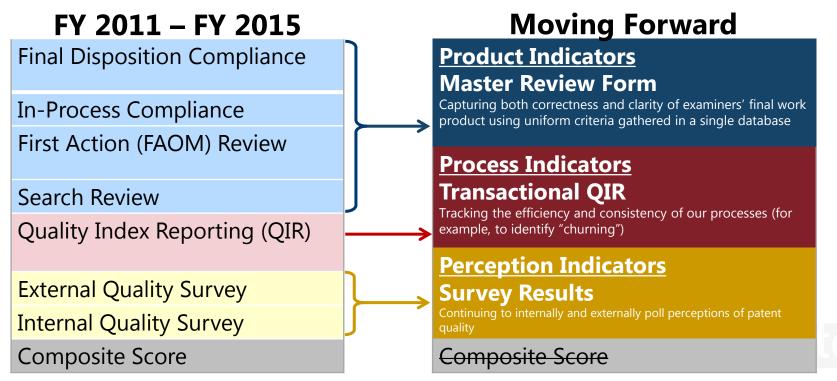
 Clarity of the Record Pilot

Pillar 3

- Post-Prosecution Pilot (P3)
- Reevaluate QPIDS
- Design Patent Publication Quality



Quality Metrics Redefined





Clarity of Record Pilot - Areas of Focus

- More detailed interview summaries
- Enhanced documentation of claim interpretation

>	Special definitions of claim terms	>	Optional language
>	Functional language	>	Non-functional descriptive material
>	Intended use or result (preamble and body of claim)		Computer-implemented functions that invoke 35 U.S.C. §112(f)
>	"Means-plus-function" (35 U.S.C. §112(f))		("specialized" or "non-specialized")

- More precise reasons for allowance
- Pre-search interview Examiner's option



Improving Clarity and Reasoning Training

35 U.S.C. 112(f): Identifying Limitations that Invoke § 112(f) 35 U.S.C. 112(f): Making the Record Clear 35 U.S.C. 112(f): Broadest Reasonable Interpretation and Definiteness of § 112(f) Limitations 35 U.S.C. 112(f): Evaluating Limitations in Software-Related Claims for Definiteness under 35 U.S.C. 112(b)

Broadest Reasonable Interpretation (BRI) and the Plain Meaning of Claim Terms

Examining Functional Claim Limitations: Focus on Computer/Softwarerelated Claims

Examining Claims for Compliance with 35 U.S.C. 112(a): Part I Written Description Examining Claims for Compliance with 35 U.S.C. 112(a): Part II – Enablement

35 U.S.C. 112(a): Written Description Workshop § 112(b): Enhancing Clarity By Ensuring That Claims Are Definite Under 35 U.S.C. 112(b)

2014 Interim Guidance on Patent Subject Matter Eligibility

Abstract Idea Example Workshops I & II Enhancing Clarity By Ensuring Clear Reasoning of Allowance Under C.F.R. 1.104(e) and MPEP 1302.14

35 U.S.C. 101: Subject Matter Eligibility Workshop III: Formulating a Rejection and Evaluating the Applicant's Response 35 U.S.C. 112(b): Interpreting Functional Language and Evaluating Claim Boundaries - Workshop

Advanced Writing Techniques utilizing Case Law



Stakeholder Training on Examination Practice and Procedure (STEPP)

- 3-Day training on examination practice and procedure for junior patent practitioners
- Provide external stakeholders with a better understanding of how and why an examiner makes decisions while examining a patent application
- Aid in compact prosecution by disclosing to external stakeholders how examiners are taught to use the MPEP to interpret an applicant's disclosure

STEPP Course Schedule

Description	Date(s)	Duration	Location
3-Day Training on Examination Practice and Procedure	November 15-17, 2016	3 Days	Alexandria, VA Campus
3-Day Training on Examination Practice and Procedure	January 10-12, 2017	3 Days	Dallas, TX – Texas Regional Office
3-Day Training on Examination Practice and Procedure	March 14-16, 2017	3 Days	San Jose, CA – Sillicon Valley Regional Office
3-Day Training on Examination Practice and Procedure	May 9-11, 2017	3 Days	Denver, CO – Rocky Mountain Regional Office
3-Day Training on Examination Practice and Procedure	July 11-13, 2017	3 Days	Alexandria, VA Campus
3-Day Training on Examination Practice and Procedure	September 19-21, 2017	3 Days	Detroit, MI – Midwest Regional Office

Post Prosecution Pilot (P3) Pilot

The Office will contact applicant to schedule P3 conference



The applicant makes a 20 minute oral presentation to panel of examiners



The Office will inform applicant in writing of decision



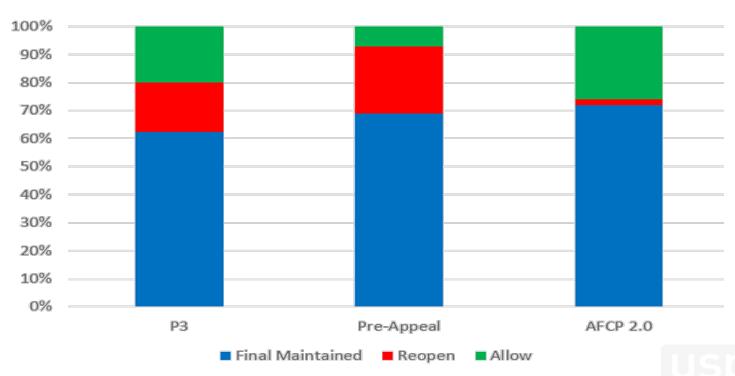
Post Prosecution Pilot – P3 (through Oct. 27, 2016)

Total Submissions	1222
Approved	1023
Defective	113
Conferences Held	614

Conference Outcomes	Count
Allowed	118
Final Maintained	368
Reopened	102
Awaiting Decision	588

P3 Outcomes

Program Outcomes – 10/24/16



AFCP 2.0 data is from start of program; Final Maintained is RCEs + Advisories Pre-Appeal data is for FY15 + FY16

Post Grant Outcomes - Objectives

 Purpose: To learn from all post grant proceedings and inform examiners of their outcomes.

1. Enhanced Patentability Determinations in Related Child Cases

 Providing examiners with full access to trial proceedings submitted during PTAB post AIA Trials

2. Targeted Examiner Training

 Data collected from the prior art submitted and examiner behavior will provide a feedback loop on best practices

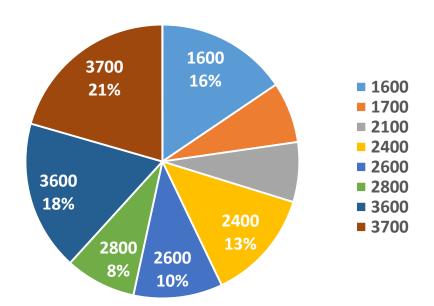
3. Examining Corps Education

 Provide examiners a periodic review of post grant outcomes focusing on technology sectors

Post Grant Outcomes

Pilot Statistics

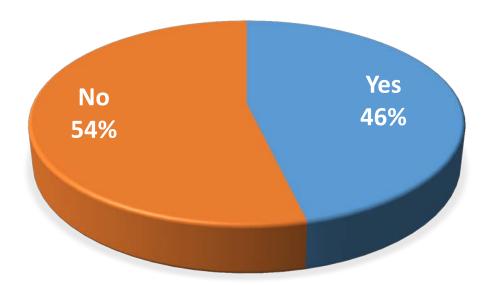
DISTRIBUTION OF PILOT APPLICATIONS
BY TECHNOLOGY CENTER



Technology Center	Number of Pilot Applications
1600	121
1700	56
2100	55
2400	102
2600	82
2800	65
3600	138
3700	160
Grand Total	779

Objective 1 – Pilot Statistics cont.

In the Office Action of the child case, did the examiner refer to any of the references cited in the AIA trial petition of the parent case?

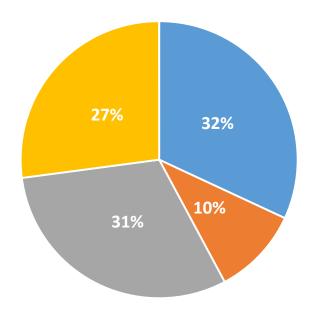




Based on 270 Survey Responses

Pilot Statistics cont.

If the examiner did not use any references cited in the AIA Trial Petition, why?



- The claims in my pilot case were substantially different from the parent case.
- I disagreed with the petitioner's analysis of the prior art and/or claims.
- I was able to find better art on my own.
- Other



1 Hour Ethics CLE available!

Patent Quality Conference

Advancing Patent Quality across the IP Community

Tuesday, Dec 13, 2016 | 8:30 a.m. - 5 p.m. EST USPTO Headquarters - Madison Auditorium

Livestream: Silicon Valley USPTO – 9:00 a.m. to 5:30 p.m.

Presentations, Panel Discussions, and Insights into the Future of Patent Quality

Examination Time Analysis - Roundtables



For additional information and ways to provide feedback please see our website at https://www.uspto.gov/patent/initiatives/eta-external-outreach

Patent Subject Matter Eligibility Roundtable Wrap-Up

Public Comment Period Closes Soon!

USPTO seeks public input on patent subject matter eligibility in view of recent decisions by the Supreme Court of the United States. The roundtable focused on receiving feedback regarding larger questions concerning the legal contours of eligible subject matter in the U.S. patent system.

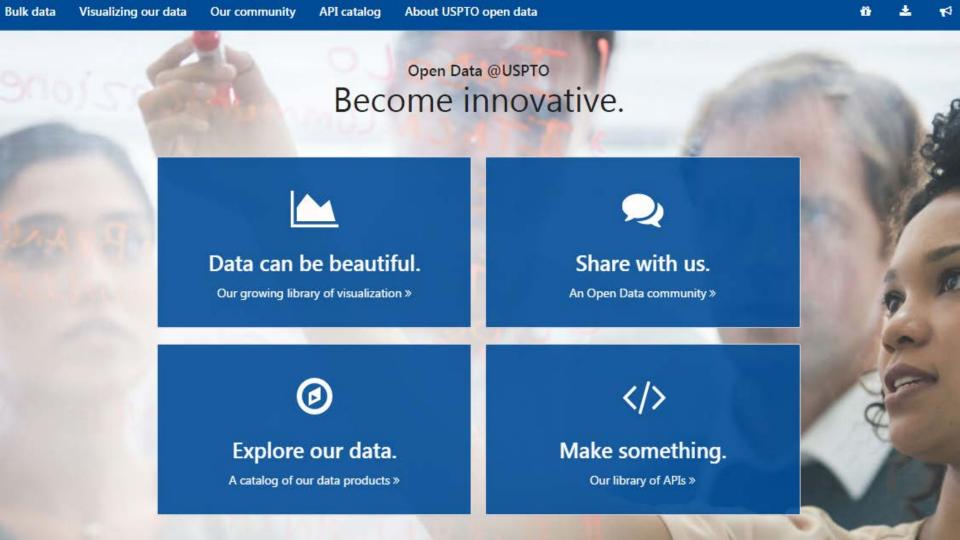
Patent Trial and Appeal Board



Open Data Portal

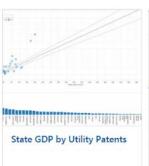
developer.uspto.gov





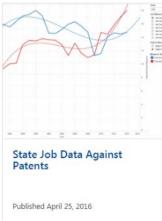
















Cancer Moonshot











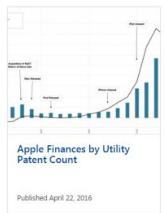




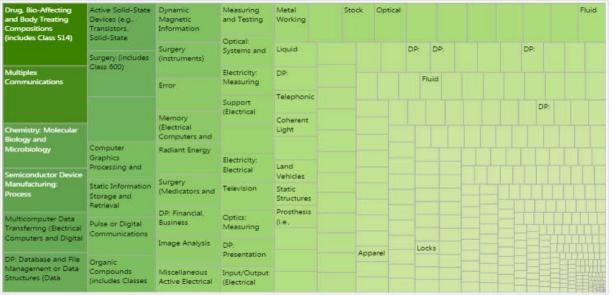




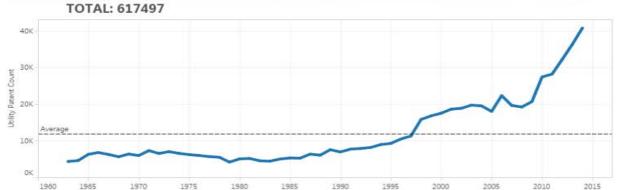




Technology Class Treemap by State

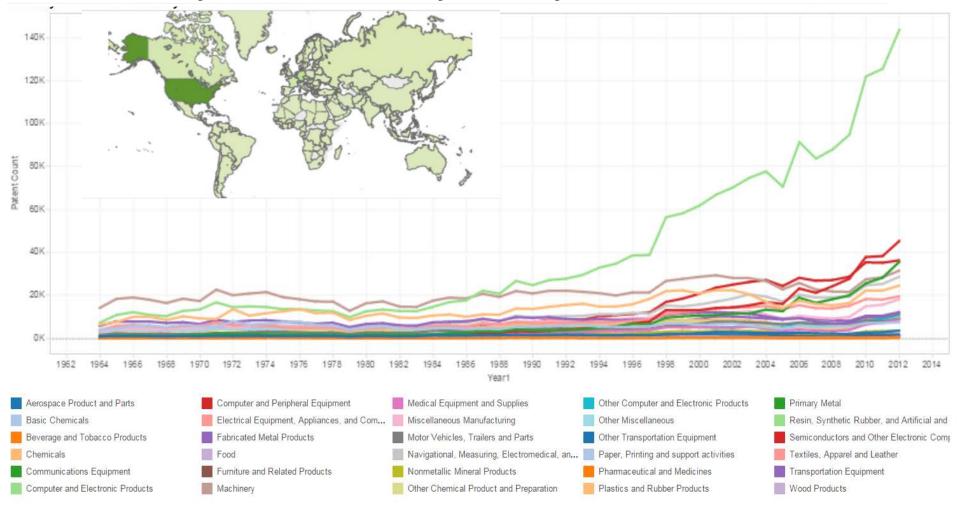






Year

NAICS Industry Classifications by Country & State (2 visuals)





www.uspto.gov/SiliconValley
https://www.facebook.com/uspto.gov
http://www.youtube.com/user/USPTOvideo/



